

FORM PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Attorney Docket No.: 19608-000230US	Application No.: 09/483,386
	Applicant: Li-Wen Chen	
	Filing Date: January 13, 2000	Group: 2776

Reference Designation	U.S. PATENT DOCUMENTS	Page 1
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Examiner Initial	Document No.	Date	Name	Class	Sub-class	Filing Date (If Appropriate)
AA	5,799,286	08/25/98	Morgan et al.	705	30	06/07/95
AB	5,794,246	08/11/98	Sankaran et al.	707	101	04/30/97
AC	5,767,854	06/16/98	Anwar	345	255 848	09/27/96
AD						
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FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Class	Sub-class	Translation (Yes/No)
AM						
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AO						
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AR						

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)
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AS	
AT	
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AV	
AW	

EXAMINER	<i>E. Colburn</i>	DATE CONSIDERED	<i>2-17-03</i>
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FORM PTO-1449 (Modified)
 LIST OF PATENTS AND PUBLICATIONS FOR
 APPLICANT'S INFORMATION DISCLOSURE
 STATEMENT (Use several sheets if necessary)

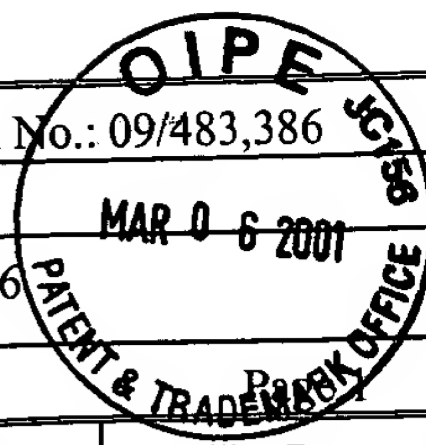
Attorney Docket No.: 19608-000230U

Application No.: 09/483,386

Applicant: Li-Wen Chen

Filing Date: January 13, 2000

Group: 2776



Reference Designation

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub-class	Filing Date (If Appropriate)
<u>EC</u> AA	5,615,109	March 25, 1997	Eder	<u>395</u> <u>705</u>	<u>208</u> <u>8</u>	
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet

2

of

2

Complete if Known

Application Number	09/483,386
Filing Date	January 13, 2000
First Named Inventor	Li-Wen Chen
Group Art Unit	2776
Examiner Name	Unknown
Attorney Docket Number	52719.00009

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
EC		HOU, Jennie, et al.; "Data Warehousing on HP3000 Using IMAGE/SQL - A New Alternative!"; HP World Conference 1998 Paper #2264; August 2-7, 1998; pages 1-30; XP-002214273; San Diego, CA.	
EC		INFORMIX SOFTWARE, INC.; "Explorer User's Guide - MetaCube™ ROLAP Option for Informix® Dynamic Server™"; January 1998; Version 4.0; pages i-vii and 1-1:2-34; XP-002214274; INFORMIX® PRESS.	
EC		GUPTA, Vivek R.; "An Introduction to Data Warehousing"; August 1997; System Services Corporation, Chicago, Illinois; XP-002204504.	
EC		GRAY, Jim, et al.; "Data Cube: A Relational Aggregation Operator Generalizing Group-By, Cross-Tab, and Sub-Totals"; Data Mining and Knowledge Discovery; 1997; pages 29-53; 1997 Kluwer Academic Publishers; XP002901286.	
EC		VASSILIADIS, Panos, et al.; "Modeling Multidimensional Databases, Cubes and Cube Operations"; Scientific and Statistical Database Management, July 1-3, 1998; IEEE Proceedings from Tenth International Conference on Capri, Italy; ISBN 0-8186-8575-1/98; XP10291092.	
EC		CHAUDHURI, Surajit, et al.; "An Overview of Data Warehousing and OLAP Technology"; Sigmod Record, Association for Computing Machinery; March 1997; pages 65-74; Vol. 26, No. 1; XP-002115173.	

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Signature

E. Colbert

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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

1

of

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09/483,386

Filing Date

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First Named Inventor

Li-Wen Chen

Group Art Unit

2776

Examiner Name _____

Unknown

Attorney Docket Number

52719.00009

U.S. PATENT DOCUMENTS

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